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Substitute Disclosure Form (PTO-1449)

Attorney's Docket No. 12406-018001

Applicant Martin Behringer et al.

Filing Date

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Application No. 15 MAR 2001

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Information Disclosure Statement

Applicant

by Applicant
(Use several sheets if necessary)

(37 CFR §1.98(b))

U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
SP	AA	5,396,103	03/07/1995	OIU et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	АН						
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Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publication	Country or			Trans	lation
Initial	ID	Number 1	Date	Patent Office	Class	Subclass	Yes	No
	AJ							_
	AK							
	AL							
	AM							
	AN					•		

(	Other D	ocuments (include Author, Title, Date, and Place of Publication)
Examiner Initial	Desig. ID	Document
SR,	AO	Magnea, N., "ZnTe fractional monolayers and dots in a CdTe matrix" 6 <sup>th</sup> International Conference on II-VI Compounds and related optoelectric materials, Journal of Crystal Growth, 138 (1994): 550-558.
SK	AP	Kutzer, V. et al., "Gain to absorption conversion by increasing excitation density in excitonic waveguides", Journal of Crystal Growth, 184/185 (1998): 632-636.
SP	AQ	Faschinger, W. et al., "Processes occurring during the formation of graded ZnSe/ZnTe contacts on p-ZnSe", Semicond. Sci. Technol., 12 (1997): 1291-1297.
SR	AR	Hirose, J. et al., "p-type conductivity control of ZnSe with insertion of ZnTe:Li submonolayers in metalorganic molecular-beam epitaxy", Journal of Applied Physics, 84 (01 DEC 1998): 6100-6104.
Sfe	AS	Fan, Y. et al., "Graded band gap ohmic contact to p-ZnSe", Applied Physics Letter, 61 (26), 28 DEC 1992: 3160-3162.

Examiner Signature Shousness flee	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if no next communication to applicant.	t in conformance and not considered. Include copy of this form with